

<b>Notice of References Cited</b>	Application/Control No. 09/970,939	Applicant(s)/Patent Under Reexamination ANDO, YASUHISA	
	Examiner Tamai IE Karl	Art Unit 2834	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,862,003	01-1999	Saif et al.	359/871
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	D	US-			
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.